IAP7 Rec'd PCT/FTO 17 JAN 2006

PTO/SB/21 (09-04)

Approved for use through 07/31/2006. OMB 0651-0031

Under the Pa	perwork Re	eduction Act of 1995	no pers	ons are required to respond to a					IT OF COMMERCE MB control number.
				Application Number			10	/553,893	
TF	RANS	MITTAL		Filing Date			10	/21/2005	
	FO	RM		First Named Inventor		Chistyakou			
				Art Unit Not Yet A			et Assigned	2821	
(to be used for	r ali corresp	ondence after initial	filina)	Examiner Name		_	Not Y	et Assigned	PHILOGEN
		erences) This Submission	7	Attorney Docket Number	er		ZOI	N-005USN	
•			EN	CLOSURES (Check	all that apply	<i>'</i>)			-
Amendm A Extensio Express Informati Certified Documen Reply to Incomple	n of Time Abandonn on Disclos Copy of P nt(s) Missing P ete Applica	eclaration(s) Request nent Request sure Statement riority arts/	Rem	Drawing(s) Licensing-related Papers Petition Petition to Convert to a Provisional Application Power of Attorney, Revoc Change of Correspondent Terminal Disclaimer Request for Refund CD, Number of CD(s) Landscape Table or	ce Address	Refer	Appea of App Appea (Appea Propri Status Other below Form	I Communication eals and Interferent Int	rences in to TC eply Brief) n lease Identify y; Copies of C1-C14; and
		ssing Parts FR 1.52 or 1.53			_				
		SIGNA	TURE	OF APPLICANT, AT	TORNEY, C	OR AG	ENT		
Firm Name	Raus	schenbach Pa	atent l	Law Group, LLC					
Signature	Ka	Haya	L	U					
Printed name Kurt Rauschenbach								-	
Date January 13, 2006			· · · · · ·	Reg. No.	40,13	7			
		rrespondence is b	eing fac	FICATE OF TRANSMI	SPTO or depos	sited with			
the date shown b		- 1 - 2 -		addressed to: Commissione	r for Patents, I	P.O. Box	(1450, /	Alexandria, VA 2	22313-1450 on
Signature		KIC	aus	Mell					
Typed or printed	name	Kurt Rausch					Date	January 13	, 2006

This collection of information is required by 37 CFR 1.5. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.11 and 1.14. This collection is estimated to 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S): Chistyakov

SERIAL NO.: 10/553,893 GROUP NO.: Not Yet Assigned

FILING DATE: October 21, 2005 EXAMINER: Not Yet Assigned

TITLE: High Density Plasma Source

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. BOX 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. §1.97, Applicants hereby make of record the references listed on the accompanying Form PTO-1449 for consideration by the Examiner in connection with the examination of the above-identified patent application. Copies of References B1-B2 and C1-C14 are enclosed.

REMARKS

In accordance with the provisions of 37 C.F.R. §1.97, this statement is being filed (CHECK ONE):

(1)	within three months of the Filing Date of a national application other than a continued prosecution application under § 1.53(d); or within three months of the date of entry of the national stage as set forth in § 1.491 in an international application; or before the mailing of a first Office Action on the merits; or before the mailing of a first Office Action after the filing of a request for continued examination under § 1.114; or
(2)	after the period defined in (1) but before the mailing date of a Final Action or Notice of Allowance, and
	the Statement required under § 1.97(e) below, OR
	the fee set forth in § 1.17(p), namely \$180.00, is included herein, or
(3)	after the mailing date of a Final Action or Notice of Allowance but before the payment of the Issue Fee, AND
П	the Statement required under § 1.97(e) below; and

Information Disclosure Statement Serial No.: 10/553,893

Page 2 of 2

the fee set forth in § 1.17(p), namely \$180.00 is included herein.

It is respectfully requested that each of the references shown on the attached Form PTO-1449 be made of record in this application.

STATEMENT

As required under §1.97(e), Applicants, through the undersigned, hereby state either that [check the appropriate space]:

- 1. That each item of information contained in the Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing date of the Information Disclosure Statement; or
- 2. That no item of information contained in the Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application, and, to the knowledge of the person signing the certification after making reasonable inquiry, no item of information contained in the Information Disclosure Statement was known to any individual designated in §1.56(c) more than three months prior to the filing of the Information Disclosure Statement.

FEE AUTHORIZATION

Applicants believe that there is no fee associated with this submission, however should it be determined that a fee is due, the Commissioner is hereby authorized to charge the missing fee to our Deposit Account No. 501211.

Respectfully submitted,

Date: January 13, 2006

Reg. No. 40,137

Tel. No.: (781) 271-1503 Fax No.: (781) 271-1527

Doc-1954v1

Kurt Rauschenbach

Atty/Agent for Applicant(s)

Rauschenbach Patent Law Group, LLC

Post Office Box 387 Bedford, MA 01730

PTO/SB/08a (08-03)

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Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number. Complete if Known Substitute for form 1449A/PTO Application Number 10/553,893 Filing Date 10/21/2005 INFORMATION DISCLOSURE First Named Inventor Chistyakov STATEMENT BY APPLICANT Art Unit Not Yet Assigned **Examiner Name** Not Yet Assigned

(Use as many sheets as necessary)

Attorney Docket Number ZON-005USN

			U. S. PATENT		·
Examiner Initials*	Cite No. ¹	Document Number Number-Kind Code ^{2 (f known)}	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
··	A1	US- 3,666,982	05-30-1972	Wiegand, Jr.	
***************************************	A2	^{US-} 4,953,174	08-28-1990	Eldridge, et al.	
·~	A3	^{US-} 5,015,493	05-14-1991	Gruen	· <u>, · · · · · · · · · · · · · · · · · ·</u>
	A4	^{US-} 5,247,531	09-21-1993	Muller-Horsche	
	A5	us- 5,795,452	08-18-1998	Kinoshita, et al.	
	A6	^{US-} 5,821,548	10-13-1998	Hinchliffe	
	Α7	^{US-} 5,846,883	12-08-1998	Moslehi	
	A8	^{US-} 6,093,293	07-25-2000	Haag, et al.	
	A9	^{US-} 6,124,675	09-26-2000	Bertrand, et al.	
	A10		09-04-2001	Haag, et al.	
	A11	^{US-} 6,296,742 B1	10-02-2001	Kouznetsov	
	A12		05-28-2002	Savas	
	A13	^{US-} 6,413,382 B1	07-02-2002	Wang, et al.	
	A14	^{US-} 6,454,920 B1	09-24-2002	Haag, et al.	
	A15	^{US-} 6,488,822 B1	12-03-2002	Moslehi	
	A16	^{US-} 2001/0047760 A1	12-06-2002	Moslehi	
***************************************	A17	^{US-} 6,853,142 B2	02-08-2005	Chistyakov	
	A18	^{US-} 6,896,773 B2	05-24-2005	Chistyakov	

	FOREIGN PATENT DOCUMENTS							
Examiner Initials*	Cite No.1	Foreign Patent Document Country Code ³ Number ⁴ Kind Code ⁵ (<i>if known</i>)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear			
	Bl	WO 98/40532	09-17-1998	Chemfilt R & D				
*******************	B2	WO 01/98553 A1	12-27-2001	Chemfilt R & D				

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	U. S. PATENT DOCUMENTS					
Examiner Initials*	Cite No.1	Document Number Number-Kind Code ^{2 (# known)}	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
	A19		05-24-2005	Chistyakov		
	A20	US- 6,805,779 B2	10-19-2004	Chistyakov		
	A21	^{US-} 2004/0060813 A1	04-01-2004	Chistyakov		
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	FOREIGN PATENT DOCUMENTS								
Examiner Initials*	Cite No.1	Foreign Patent Document Country Code ³ Number ⁴ 'Kind Code ³ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶			
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Substitute fo	or form 1449B/PTO			Complete if Known			
				Application Number	10/553,893		
INFO	RMATION DI	SCLO	SURE	Filing Date	10/21/2005		
STAT	TEMENT BY	APPLI	CANT	First Named Inventor	Chistyakov		
				Art Unit	Not Yet Assigned		
	(Use as many sheets as	necessary)	1	Examiner Name	Not Yet Assigned		
Sheet	3	of	4	Attorney Docket Number	ZON-005USN		

		NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²
	C1	BOOTH, ET AL., The Transition From Symmetric To Asymemtric Discharges In Pulsed 13.56 MHz Capacitively Coupled Plasmas, J. Appl. Phys., 15 July 1997, Pgs. 552-560, Vol. 82, No. 2, American Institute of Physics.	
	C2	BUNSHAH, ET AL., Deposition Technologies For Films And Coatings, Pgs. 178-183, Noyes Publications, Park Ridge, New Jersey.	
•••••••••••	C3	DAUGHERTY, ET AL., Attachment-Dominated Electron-Beam-Ionized Discharges, Applied Physics Letters, 15 May 1976, Pgs. 581-583, Vol. 28, No. 10, American Institue of Physics.	
***************************************	C4	GOTO, ET AL., Dual Excitation Reactive Ion Etcher For Low Energy Plasma Processing, J. Vac. Sci. Technol. A., Sep/Oct 1992, Pgs. 3048-3054, Vol. 10, No. 5, American Vacuum Society.	
	C5	KOUZNETSOV, ET AL., A Novel Pulsed Magnetron Sputter Technique Utilizing Very High Target Power Densities, Surface and Coatings Technology, 1999, Pgs. 290-293, Vol. 122, Elsevier Science S.A.	
	С6	LINDQUIST, ET AL., High Selectivity Plasma Etching Of Silicone Dioxide With A Dual Frequency 27/2 MHz Capacitive RF Discharge.	
	С7	MACAK, Reactive Sputter Deposition Process Of Al203 And Characterization Of A Novel High Plasma Density Pulsed Magnetron Discharge, Linkoping Studies In Science And Technology, Pgs. 1-2.	
	C8	MACAK, ET AL., Ionized Sputter Deposition Using An Extremely High Plasma Density Pulsed Magnetron Discharge, J. Vac. Sci. Technol. A., Jul/Aug 2000, Pgs. 1533-1537, Vol. 18, No. 4., American Vacuum Society.	
	С9	MOZGRIN, ET AL., High-Current Low-Pressure Quasi-Stationary Discharge In A Magnetic Field: Experimental Research, Plasma Physics Reports, 1995, Pgs. 400-409, Vol. 21, No. 5.	
	C10	ROSSNAGEL, ET AL., Induced Drift Currents In Circular Planar Magnetrons, J. Vac. Sci. Technol. A., Jan/FEb 1987, Pgs. 88-91, Vol. 5, No. 1, American Vacuum Society.	

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ı	Examiner	Date	
l	Signature	Considered	

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached. This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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				Application Number	10/553,893	
INFOF	RMATION DI	SCLO	SURE	Filing Date	10/21/2005	
STAT	EMENT BY	APPLI	CANT	First Named Inventor	Chistyakov	
				Art Unit	Not Yet Assigned	
	(Use as many sheets as	s necessary))	Examiner Name	Not Yet Assigned	
Sheet	4	of	4	Attorney Docket Number	ZON-005USN	

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Examiner Initials*	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
	C11	SHERIDAN, ET AL., Electron Velocity Distribution Functions In A Sputtering Magnetron Discharge For The E x B Direction, J. Vac. Sci. Technol. A., Jul/Aug 1998, Pgs. 2173-2176, Vol. 16, No. 4, American Vacuum Society.
	C12	STEINBRUCHEL, A Simple Formula For Low-Energy Sputtering Yields, Appl. Phys. A., 1985, Pgs. 37-42, Vol. 36, Sprigner Verlag.
		Encyclopedia Of Low Temperature Plasma, Pa. 119, Vol. 3
	C13	
000000000000000000000000000000000000000	***************************************	Encyclonedia Of Low Temperature Plasma, Pg. 123, Vol. 3
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